

L Number	Hits	Search Text	DB	Time stamp
1	47	(capacitor near (upper top) near electrode) near5 (spacer sidewall)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 09:35
2	23	(capacitor near (upper top) near electrode) near5 spacer	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 09:46
3	6	capacitor near (upper top) near electrode near spacer	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 09:48
4	1	spacer near capacitor near (upper top) near electrode	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 09:49
5	6	capacitor with ((upper top) near electrode near spacer)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 09:52
6	24	capacitor\$1 and ((upper top) near electrode near spacer\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 09:53
7	5	("6011284" "6144060" "6201726" "6242299" "6396092").PN.	USPAT	2004/06/17 09:55
8	24	("4145803" "4481283" "4890191" "5037773" "5053917" "5099305" "5138411" "5182232" "5187638" "5227855" "5241201" "5278091" "5293510" "5349494" "5366920" "5369296" "5418180" "5429972" "5443688" "5444013" "5495117" "5555486" "5595928" "5612082").PN.	USPAT	2004/06/17 09:59
9	36	("4145803" "4481283" "4890191" "5037773" "5053917" "5099305" "5138411" "5182232" "5187638" "5217914" "5223448" "5227855" "5241201" "5278091" "5293510" "5349494" "5366920" "5369296" "5418150" "5418180" "5429972" "5443688" "5444013" "5495117" "5555486" "5595928" "5612082" "5696017" "5741722" "5793076" "5940676" "6037206" "6066528" "6077737" "6080621" "6083788").PN.	USPAT	2004/06/17 10:04

L Number	Hits	Search Text	DB	Time stamp
1	2	("6043526").PN.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 16:20
2	160	etch\$ with (gas\$2 near5 (CHF3 CF4 Ar N2) near5 ((insulat\$3 dielectric) near (layer film)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 18:39
3	27	(etch\$ with (gas\$2 near5 (CHF3 CF4 Ar N2) near5 ((insulat\$3 dielectric) near (layer film)))) and (capacitor\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 18:01
6	19	stack\$3 near2 (conduct\$3 adhesive) near2 ((lower bottom) near electrode)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 17:57
7	2413	(conduct\$3 adhesive) near2 ((lower bottom) near electrode)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 18:01
8	0	(conduct\$3 adhesive) near2 (before near stack\$3) near2 ((lower bottom) near electrode)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 17:58
9	8	(conduct\$3 adhesive) near2 before near2 ((lower bottom) near electrode)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 17:59
10	1387	((conduct\$3 adhesive) near2 ((lower bottom) near electrode)) and (capacitor\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 18:01
11	117	adhesive near2 ((lower bottom) near electrode)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 18:01
12	73	(adhesive near2 ((lower bottom) near electrode)) and (capacitor\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 18:02
13	27	etch\$ with (gas\$2 near5 (O2 oxygen CHF3 CF4 Ar N2) near5 ((top upper) near electrode))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 18:41
14	26	etch\$ with (gas\$2 near5 (O2 oxygen Cl2 BCl3 Ar HBr) near5 ((top upper) near electrode))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/17 18:41